



Test of Amorphous Silicon Detectors on the Trento Proton Beam Line

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Goal of the HASPIDE project

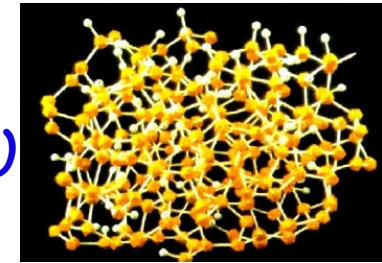


Creation of thin α -Si:H (1 - 10 μm) ionizing radiation detectors deposited over thin plastic substrate to be used for:

- *beam monitoring of medical LINACs and other types of accelerators*
- *detection of radiation bursts in space, for example Solar Energetic Particles events;*
- *neutron detection via ^{10}B deposition over an α -Si:H layer to detect α produced by neutron conversion.*

Why $a\text{-Si:H}$ as detection material?

- Highly disordered material → radiation damage resistant;
- *Thin film deposition with several techniques (PECVD most used)*
- High level of industrial production for standard applications (solar cells, flat panel for X-ray imaging)
- *Easy deposition at moderate (PECVD) and low (PLD) temperature on flexible surfaces like kapton*
- Wide area deposition is possible at lower costs than for corresponding crystalline silicon deposition.
- **Already used in beam monitoring at CNAO.**

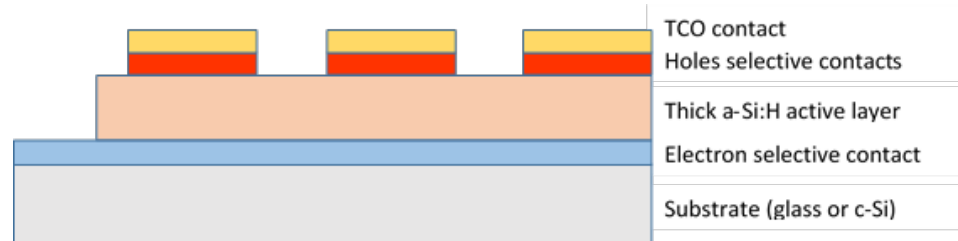




Status of device production



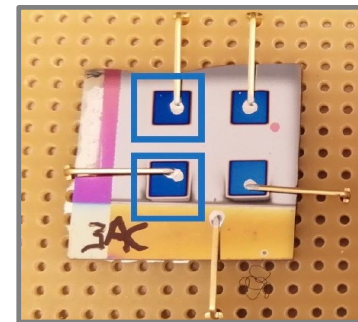
Several batches of $a\text{-Si:H}$ depositions on polyimide has been produced (PECVD).



$2 \times 2 \text{ mm}^2$ and $5 \times 5 \text{ mm}^2$ devices (p-i-n) are available for cutting and testing.

Thickness: $2.5 \mu\text{m}$.

Polyimide thickness: $25 \mu\text{m}$





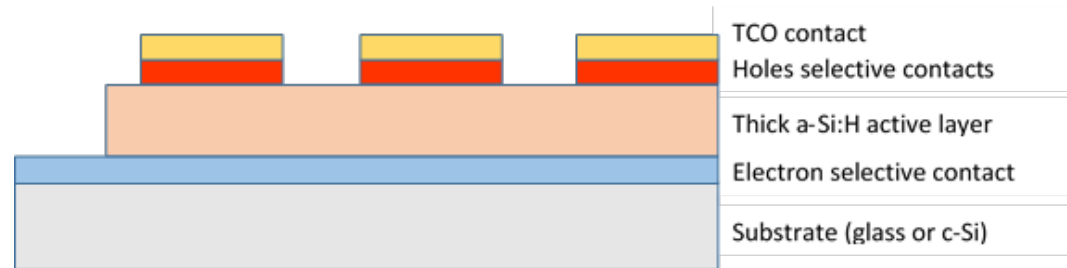
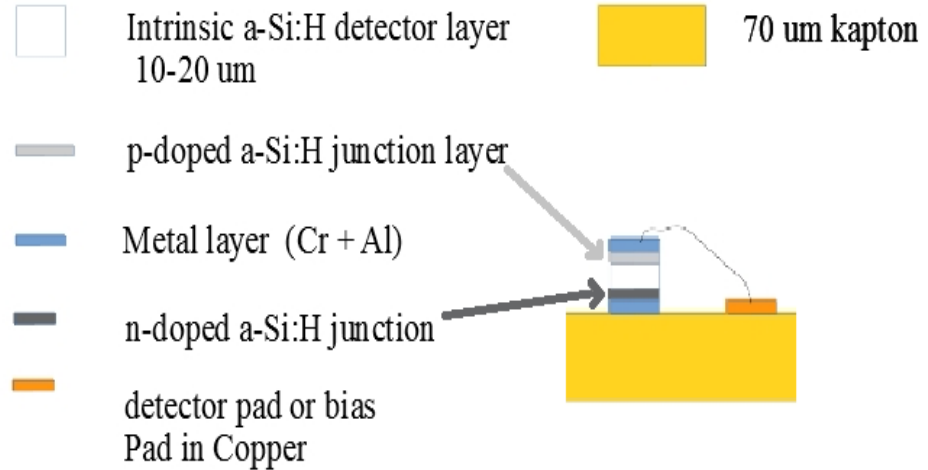
Status of device production



Two different type of contacts under study:

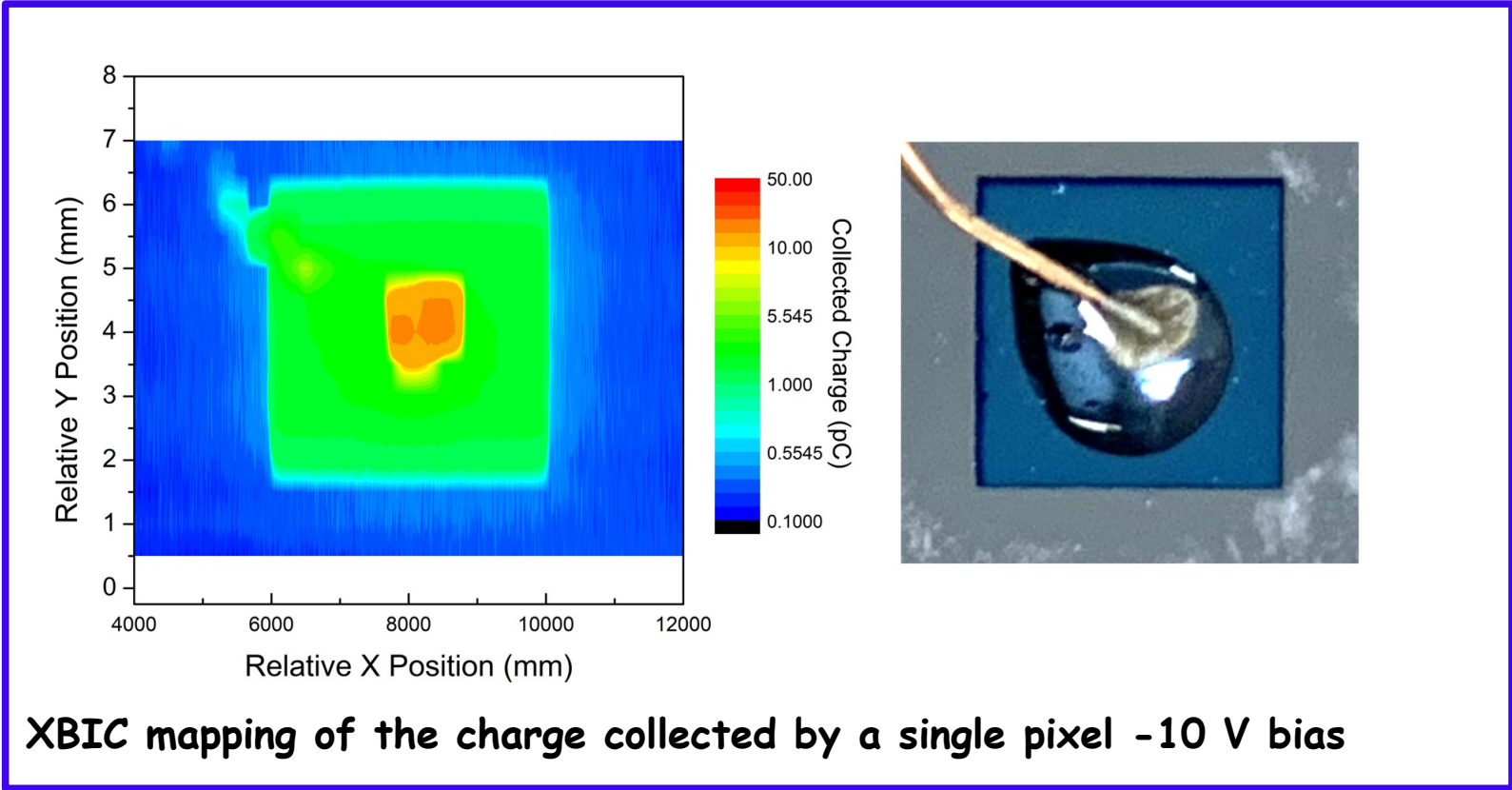
→ *n-i-p* devices

→ *Charge selective contacts*





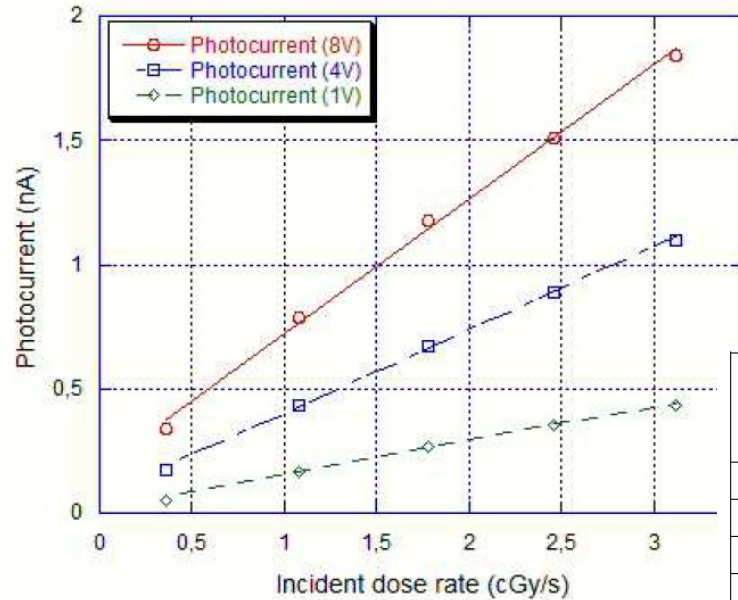
Results: Charge collection only below electrode.



XBIC mapping of the charge collected by a single pixel -10 V bias



Test with photon beams, X-ray.



Current vs incident dose-rate (X-ray source) for 2x2 mm device at various bias.

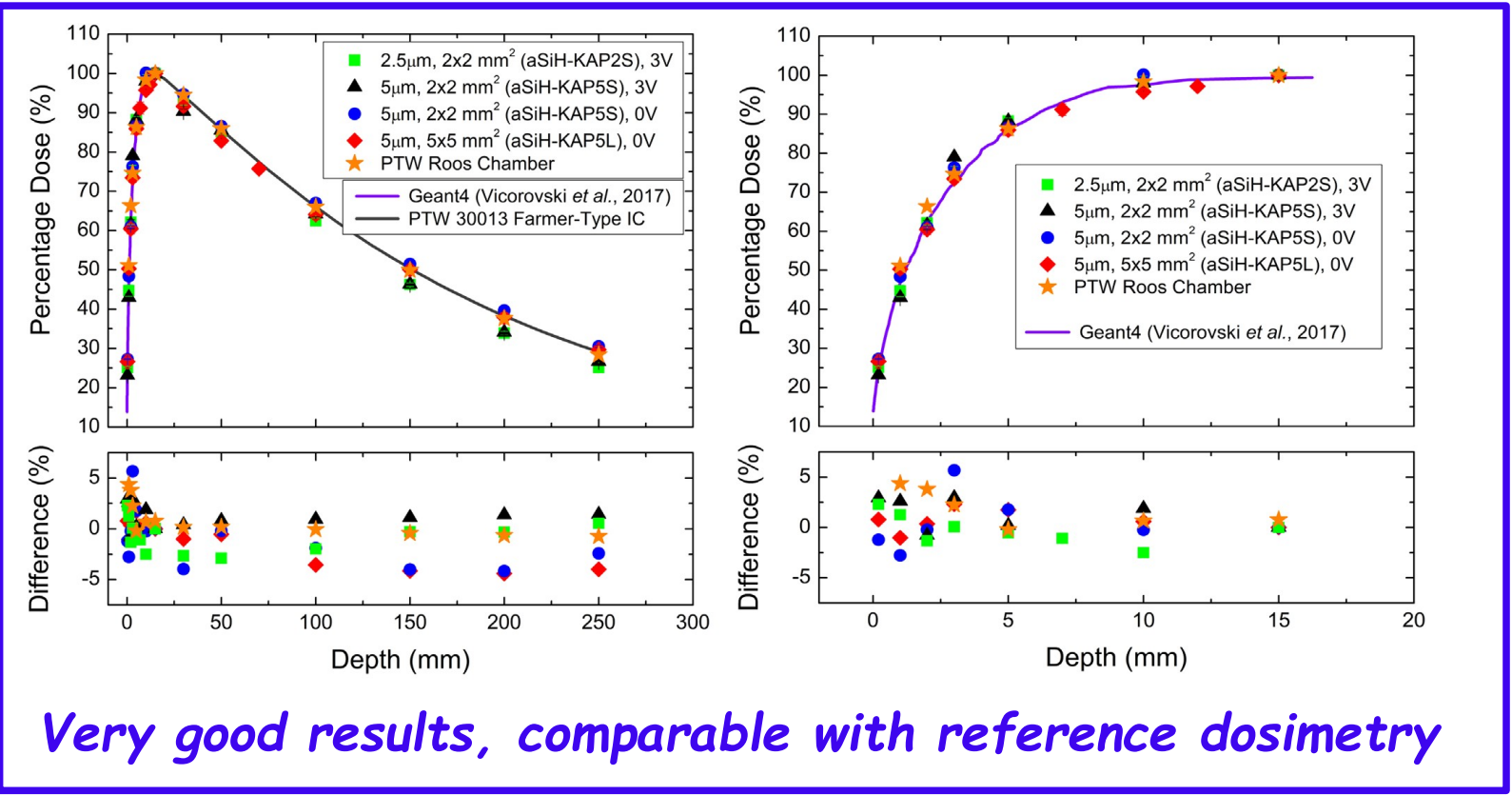
Noise ~ few pA.

Sensitivity for different devices and bias.

Device Area (mm ²)	Bias Voltage	Dosimetric sensitivity (nC/cGy)	Regression coefficient R
5 x 5	0V	0.367	0.99999
	2V	1.283	0.99991
	4V	1.900	0.99975
	6V	2.505	0.99972
	8V	3.027	0.99926
2 x 2	1V	0.137	0.99878
	4V	0.335	0.99961
	8V	0.540	0.99881

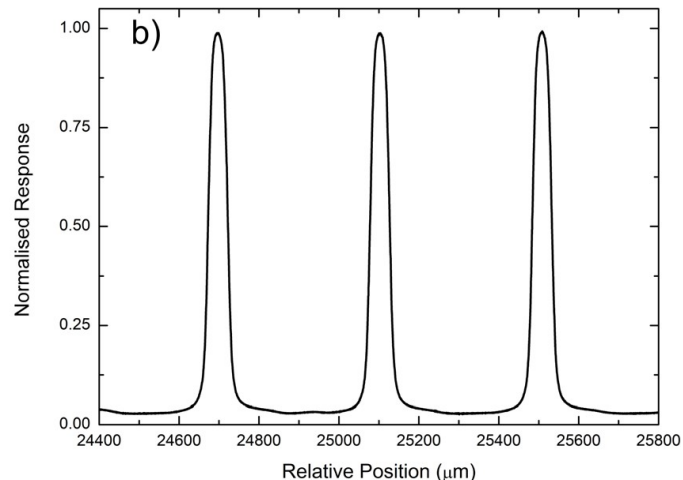
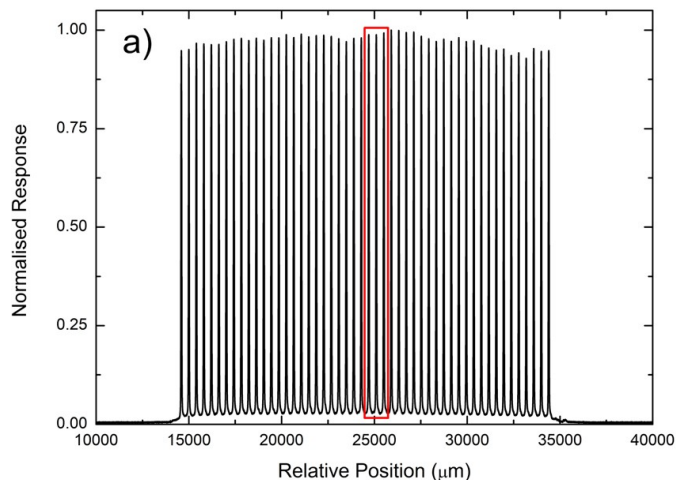


Test with photon beams: clinical MV beams.





Test with photon beams: microbeam profile.



Using 0.8 μm thick device edge-on wrt beam spatial reconstruction of microbeams 50 μm wide could be obtained.



Tests done on proton beam at APSS

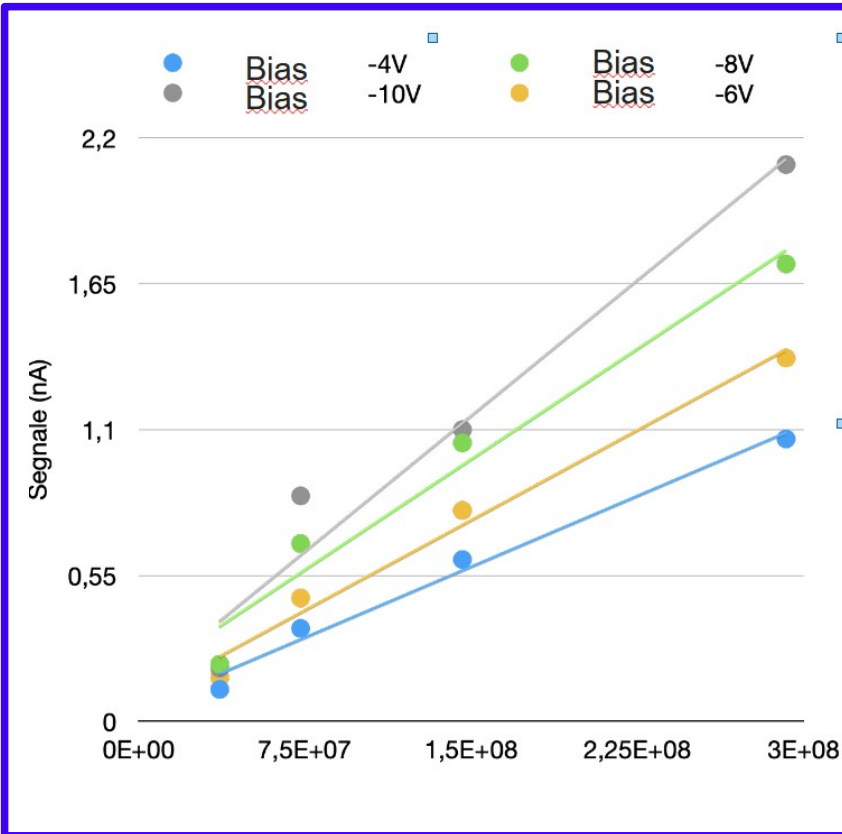


HASPIDE need to test devices also on charged particle beams.

- verify the radiation flux measurement capabilities for different types of radiation.*
- measure the sensitivity to small proton fluxes for Space Weather use.*
- First test done in 2023. Second one ongoing this week.*



Tests done on proton beam at APSS



Preliminary results:

Sensor K2_P3 : n-i-p,
area 5x5 mm²

thickness 2.5 μm.

Proton energy: 148 MeV.

charge collection efficiency
~ 24% for 0.8 10⁷ p/s

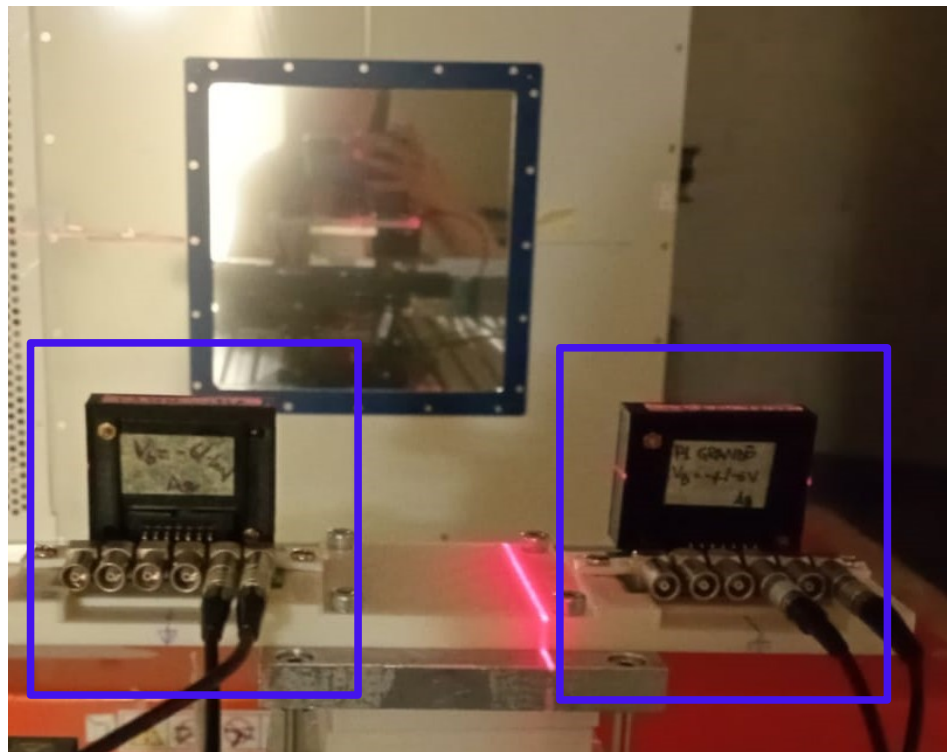


Tests ongoing at APSS proton beam



2 series of devices
under test:
both 2x2 and 5x5 mm²
area, 2.5 μm thickness:

- *n-i-p* contacts
- *CSC* contacts





Tests ongoing at APSS proton beam



Goals:

- 1) *compare the two different contact technologies*
- 2) *verify linearity of response vs flux for different proton energies*
- 3) *verify response vs bias to study Charge Collection Efficiency*



Tests ongoing at APSS proton beam



Goals:

- 1) *compare the two different contact technologies*
- 2) *verify linearity of response vs flux for different proton energies*
- 3) *verify response vs bias to study Charge Collection Efficiency*



What we would like to have....



- *an independent method to measure the protons/s for lower fluxes, ideally 10^5 protons/s or lower.*
This is relevant for the Space Weather application where we need to detect 400 MeV protons after they have been degraded to an energy of few MeV.
- *Access to the APSS proton FLASH mode to test our devices.*
Up to know we have done test at the Australian Synchrotron for *photon beams*.
We are starting tests at *Electron FLASH* accelerator in Pisa.